Notice of Allowability	Application No.	Applicant(s)	Applicant(s)	
	09/768,356	OSE ET AL.		
	Examin r	Art Unit		
	Jack I. Berman	2881		
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in to or other appropriate communing GHTS. This application is sulfi-	his application. If not incluication will be mailed in du	ided le course <b>THIS</b>	
<ol> <li>This communication is responsive to the amendment filed of the allowed claim(s) is/are 1-3,5,6 and 8-17.</li> <li>The allowed claim(s) is/are 1-3,5,6 and 8-17.</li> <li>The drawings filed on 25 January 2001 are accepted by the 4. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the:         <ol> <li>Certified copies of the priority documents have</li> <li>Certified copies of the priority documents have</li> <li>Copies of the certified copies of the priority documents have</li> <li>Copies of the certified copies of the priority documents have</li> </ol> </li> <li>* Certified copies not received:         <ol> <li>Acknowledgment is made of a claim for domestic priority un reference was included in the first sentence of the specifical (a) The translation of the foreign language provisional all Acknowledgment is made of a claim for domestic priority un in the first sentence of the specification or in an Application</li> </ol> </li> </ol>	e Examiner.  der 35 U.S.C. § 119(a)-(d) or  been received.  been received in Application cuments have been received in  der 35 U.S.C. § 119(e) (to a particular or in an Application Data application has been received.  der 35 U.S.C. §§ 120 and/or	No  In this national stage application) sin Sheet. 37 CFR 1.78.	ce a specific	
Applicant has THREE MONTHS FROM THE "MAILING DATE" of below. Failure to timely comply will result in ABANDONMENT of to 7.   A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give	this communication to file a re his application. THIS THREE tted. Note the attached EXAM	E-MONTH PERIOD IS NOT INER'S AMENDMENT or	T EXTENDABLE.	
<ul> <li>8.  CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftsperson 1) hereto or 2) to Paper No</li> <li>(b) including changes required by the proposed drawing control (c) including changes required by the attached Examiner's</li> </ul>	t be submitted. on's Patent Drawing Review( orrection filed, which h	PTO-948) attached as been approved by the		
Identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in th	34(c)) should be written on the c e margin according to 37 CFR 2	drawings in the front (not th I.121(d).	e back) of	
<ol> <li>DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT FOR THE</li> </ol>	it of BIOLOGICAL MATER HE DEPOSIT OF BIOLOGICA	IAL must be submitted. L MATERIAL.	Note the	
Attachment(s)				
<ul> <li>Notice of References Cited (PTO-892)</li> <li>Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>Information Disclosure Statements (PTO-1449 or PTO/SB/08)         Paper No</li> <li>Examiner's Comment Regarding Requirement for Deposit         of Biological Material</li> </ul>	6□ Interview Summ 7□ Examiner's Ame	nal Patent Application (PTC nary (PTO-413), Paper No. endment/Comment ement of Reasons for Allo	· ·	
		JUL BOUMAN JACK BERMAN PRIMARY EXAMINER		

Application/Control Number: 09/768,356

Art Unit: 2881

The following is an examiner's statement of reasons for allowance: While electrostatic octapole deflectors per se are known in the art (see Okubo, which describes electrostatic deflectors comprising octupole metal electrodes fixed to the inside of an insulating sheath as "conventional" beginning at line 19 in column 1), there is no suggestion in the prior art to locate such an octapole deflector at the principle plane of the objective lens of a scanning electron microscope, or between the objective lens and a sample, while a second deflector is provided closer to the electron source. The prior art also does not disclose a scanning electron microscope having a setting means, for setting a position to which an image shifting deflector system shifts an image, and a setting nullifying means that, responsive to a position set by the setting means being in a specific region including a center of a deflection range for the image shifting deflector system, nullifies the position set by the setting means or provides a warning.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jack I. Berman whose telephone number is (703) 308-4849. The examiner can normally be reached on M-F (8:30-6:00) with every second Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R. Lee can be reached on (703) 308-4116. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9318.

Art Unit: 2881

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Jack I. Berman

Jack I. Berman

Primary Examiner

Art Unit 2881

jb December 4, 2003